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Substitute for form 1449/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Complete if Known

Application Number	10/801,981
Filing Date	03/16/2004
First Named Inventor	Diane K. Stewart
Art Unit	N/A
Examiner Name	N/A
Attorney Docket Number	F118 ACIP

Sheet	1	of	2
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U. S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

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Examiner
Signature

Beverly Souw

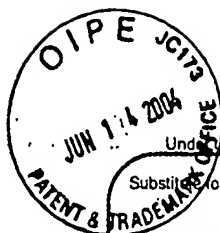
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03/23/05

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PTO/SB/088 (08-03)

Approved for use through 07/31/2006. OMB 0651-0031

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NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
BES	I	C.K. CRAWFORD, Charge Neutralization Using Very Low Energy Ions, Scanning Electron Microscopy, 1979, II, SEM Inc., USA	
BES	J	ALBERT FOLCH ET AL., High Vacuum Versus, "Environmental" Electron Beam Deposition, Jul/Aug. 1996, B 14(4), PP. 2609-2614, J. Vac. Sci.	
BES	K	YUKINORI OCHIAI, Electron-Beam-Induced Deposition of Copper with Low Resistivity, Nov/Dec. 1996, B 14(6), PP. 3887-3891, J. Vac. Sci. Technol.	

Examiner
Signature

Bernard Souw

Date
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NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
BES	C	WITOLD SLOWKO AND HERBERT PRASOL, "Micro-Sphere Plate as an Electron Detector at Low Vacuum," Vacuum, Vol. 67, (2002) pp. 191-198	
BES	D	M. JACKA, M. ZADRAZIL AND F. LOPOUR, "A Differentially Pumped Secondary Electron Detector for Low-Vacuum Scanning Electron Microscopy," Scanning, Vol. 25, (2003) pp. 243-246	
BES	E	WITOLD SLOWKO, "Secondary Electron Detector with a Micro-Porous Plate for Environmental SEM," Vacuum, Vol. 63, (2001) pp. 457-461	

Examiner Signature	Bernard Souw	Date Considered	03/23/05
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